

Form PTO-1449					U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1829		SERIAL NO. 10/072,440	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT H. Daniel Dulman					
					FILING DATE Feb. 5, 2002 (RCE Filed Herewith)		GROUP 1756			
U.S. PATENT DOCUMENTS										
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate			
<i>DL</i>	AA	5,629,113	05/97	Watanabe	<i>430</i>	<i>5</i>				
	AB	6,007,324	12/99	Tzu et al.	<i>RECEIVED 5</i>					
	AC	5,384,219	01/95	Dao et al.	<i>FEB 10 2004 5</i>					
	AD	5,300,379	01/94	Dao et al.	<i>OFFICE OF PETITIONS</i>					
<i>DL</i>	AE	5,897,975	04/99	Ahn et al.	<i>430</i>	<i>5</i>				
	AF									
	AG									
	AH									
	AI									
	AJ									
	AK									
FOREIGN PATENT DOCUMENTS										
		Document Number	Date	Country	Class	Subclass	Translation			
	AL	US 03/ 02288	01/03	PCT Search Report			Yes	No		
	AM	0 395 425 A2/A3	04/90	EPO						
	AN	0 583,942 A2	08/93	EPO						
	AO									
	AP									
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)										
<i>DL</i>	AQ	Cui, Z. et al., "Partial Rim: A New Design of Rim Phase Shift Mask for Submicron Contact Holes", SPIE Vol. 2440, Feb. 1995, pp. 541-549.								
	AR									
	AS									
EXAMINER <i>H. Daniel Dulman</i>				DATE CONSIDERED <i>3/2/04</i>						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.										